



B
Uw

00862.022171

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: K. Nguyen
Takayuki YAGI et al.)	
	:	Group Art Unit: 2881
Application No.: 09/819,672 ✓)	
	:	Confirmation No.: 3159
Filed: March 29, 2001)	
	:	Allowed: October 20, 2004
For: ELECTRON OPTICAL SYSTEM ARRAY,)	
CHARGED-PARTICLE BEAM EXPOSURE	:	October 29, 2004
APPARATUS USING THE SAME, AND)	
DEVICE MANUFACTURING METHOD	:	

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST FOR CORRECTED NOTICE OF ALLOWANCE

Sir:

Applicants have received a Notice of Allowance and a Notice of Allowability dated October 20, 2004, in the above-identified application, in which the Notice of Allowance lists the TITLE OF INVENTION as "ELECTRON OPTICAL SYSTEM ARRAY, CHARGED-PARTICLE BEAM EXPOSURE APPARATUS USING THE SAME, AND DEVI MANUFACTURING METHOD."


The title as listed contains a misspelled word. Specifically, the fourteenth word "DEVI" should read -- DEVICE --. Applicants, therefore, request that the TITLE OF THE INVENTION be corrected to read -- ELECTRON OPTICAL SYSTEM ARRAY, CHARGED-PARTICLE BEAM EXPOSURE APPARATUS USING THE SAME, AND **DEVICE** MANUFACTURING

METHOD --. Accordingly, Applicants request that a corrected Notice of Allowance be issued to make this correction.

Applicants believe that no fees should be incurred in connection with filing this paper. Nevertheless, the Commissioner is authorized to charge Deposit Account No. 06-1205 should any fees be associated therewith. A duplicate of this document is enclosed for this purpose.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our below-listed address.

Respectfully submitted,



Attorney for Applicants
Steven E. Warner
Registration No. 33,326

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200
SEW/cab